



PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
AUG 21 2003  
TC 2800 MAIL ROOM

APPLICANTS: VON AMMON ET AL 9  
SERIAL NO.: 09/813,240 EXAMINER: J. MONDT  
FILED: MARCH 20, 2001 GROUP: 2826  
TITLE: SEMICONDUCTOR WAFER MADE FROM SILICON AND  
METHOD FOR PRODUCING THE SEMICONDUCTOR WAFERS

RESPONSE TO NON-FINAL OFFICE ACTION

MAIL STOP - FEE AMENDMENT  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Non-Final Office Action dated  
April 15, 2003, with the time for reply having been extended for  
one month from JULY 15, 2003, until AUGUST 15, 2003.

Remarks begin on Page 2 of this document.